



Filed Via Express Mail pursuant to 37 C.F.R. 1.10

Rec. No.: EV 332 248 208 US

On: APRIL 23, 2004

By: *Linda E. Hastings*

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECF 18.591 (100806-17366)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Takaaki NAGAI
Serial No.: 09/837,734
Filed: April 17, 2001
Title: **NON-VOLATILE SEMICONDUCTOR STORAGE
APPARATUS AND MANUFACTURING METHOD THEREOF**
Examiner: Douglas W. Owens
Group Art Unit: 2811

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

SIR :

In response to the Office Action dated October 24, 2003, the period for responding thereto expiring after January 24, 2004, the period for response not being extended for more than three months, please amend the subject application as follows: